



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## BIB DATA SHEET

CONFIRMATION NO. 5254

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/518,345	12/17/2004	438	1795	075834.00404		
<b>RULE</b>						
<b>APPLICANTS</b> Yoko Watanabe, Tokyo, JAPAN; Shinji Omori, Kanagawa, JAPAN; Kazuya Iwase, Kanagawa, JAPAN; Keiko Amai, Kanagawa, JAPAN; Masaki Yoshizawa, Kanagawa, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/08176 06/27/2003						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-191099 06/28/2002 JAPAN 2003-129523 05/07/2003						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 01/26/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /JONATHAN G JELSMAN/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 13	<b>TOTAL CLAIMS</b> 28	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> ROBERT J. DEPKE LEWIS T. STEADMAN ROCKEY, DEPKE & LYONS, LLC SUITE 5450 SEARS TOWER CHICAGO, IL 60606-6306 UNITED STATES						
<b>TITLE</b> Mask, Method of Inspecting the Same, and Method of Producing Semiconductor Device						
<b>FILING FEE RECEIVED</b> 1300	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		